

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Plat et al.

Serial No .: -

10/079,775

Filed:

February 19, 2002

Group Art Unit:

2823

Before the Examiner:

Lee, Hsien Ming

Title:

A METHOD FOR REDUCING ANTI-REFLECTIVE COATING LAYER REMOVAL DURING REMOVAL OF

PHOTORESIST

REPLY UNDER 37 C.F.R. § 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Aléxandria, VA 22313-1450

Dear Sir:

In response to the Office Action having a mailing date of January 10, 2005, having a three-month shortened statutory period for response set to expire on April 10, 2005, please reconsider the rejections of the claims in view of the following remarks:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks begin on page 11 of this paper.

CERTIFICATION UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on February 1, 2005.

Signature

Serena Beller

(Printed name of person certifying)

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